

FIG. 1

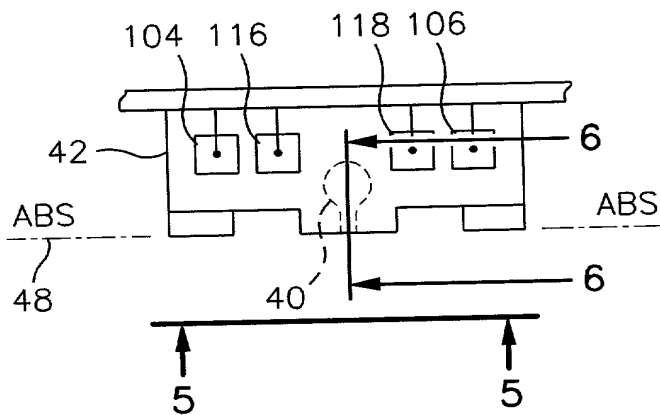


FIG. 2

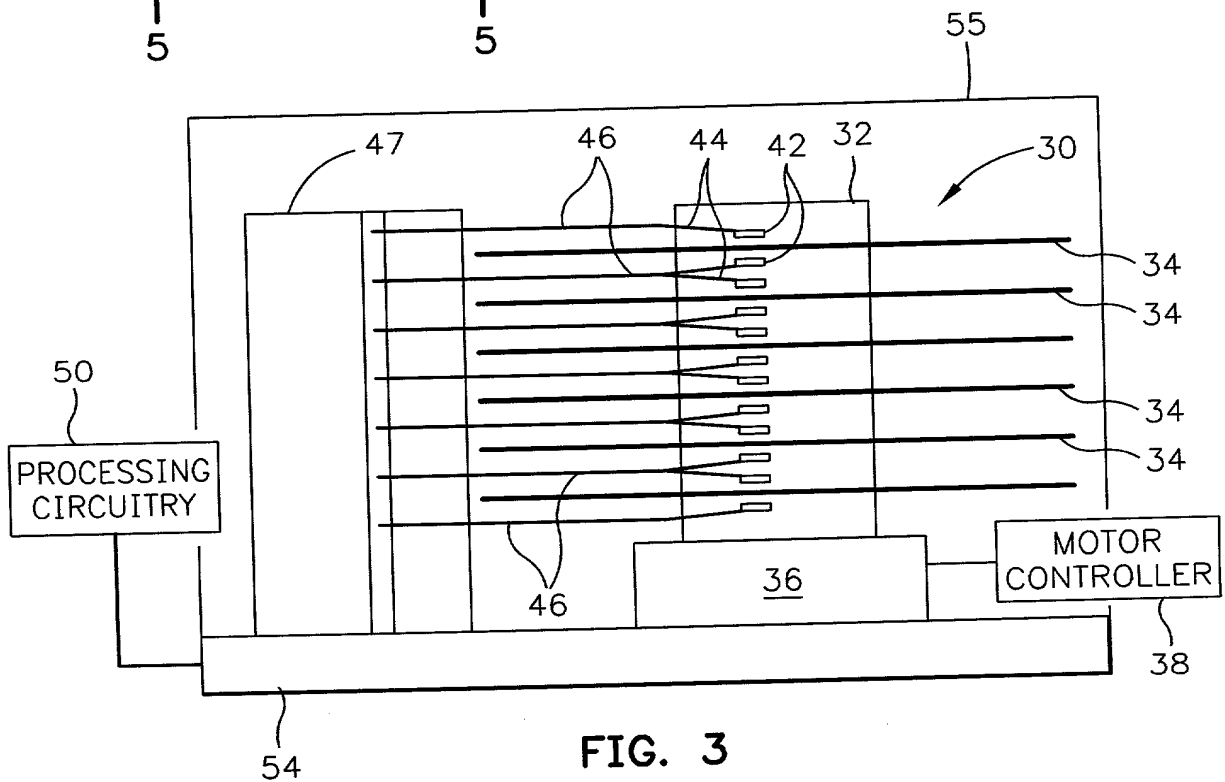


FIG. 3

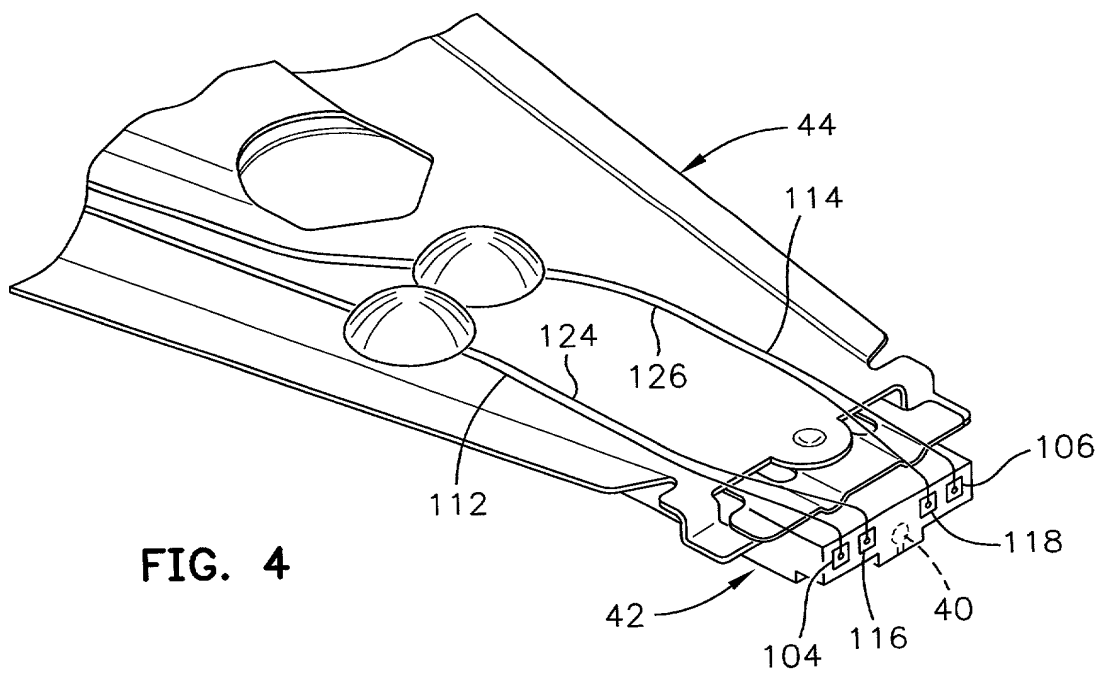


FIG. 4

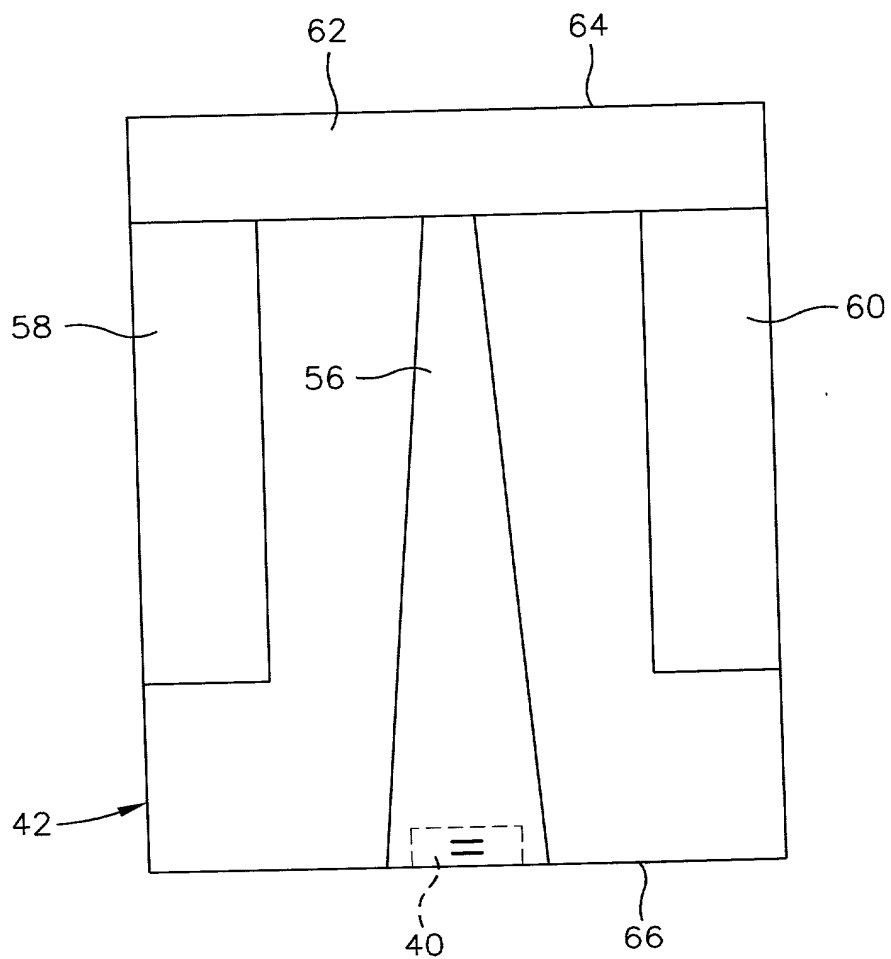


FIG. 5

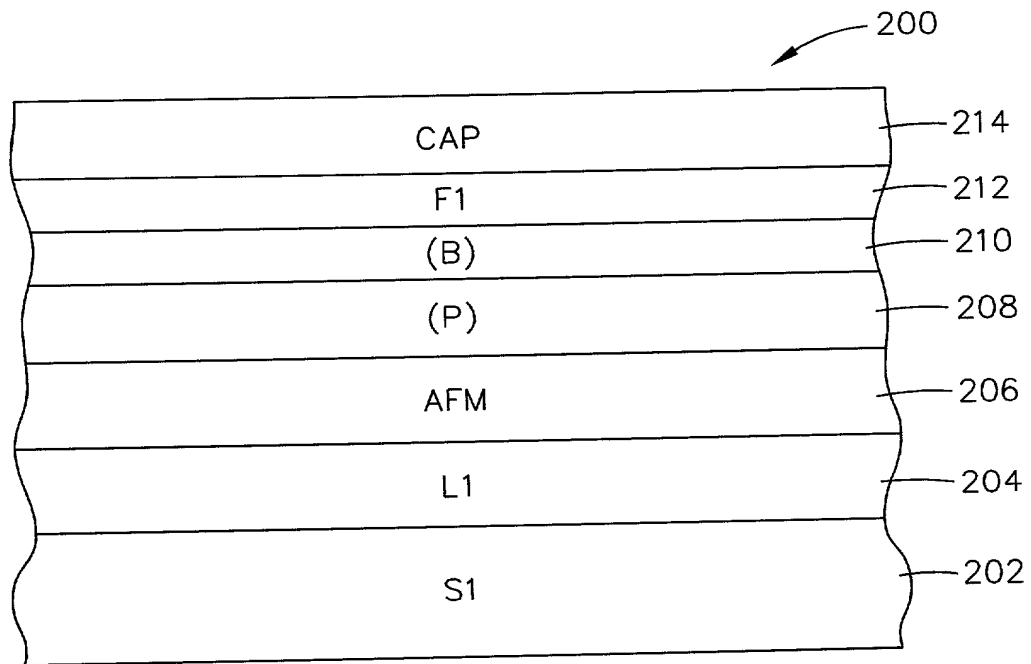


FIG. 9

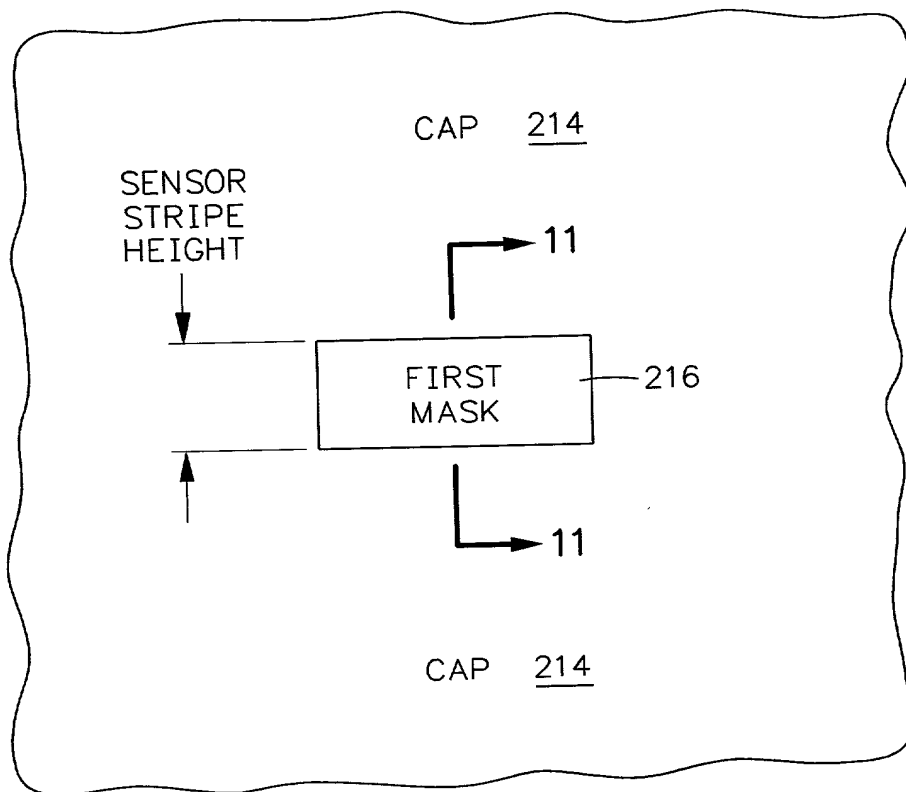
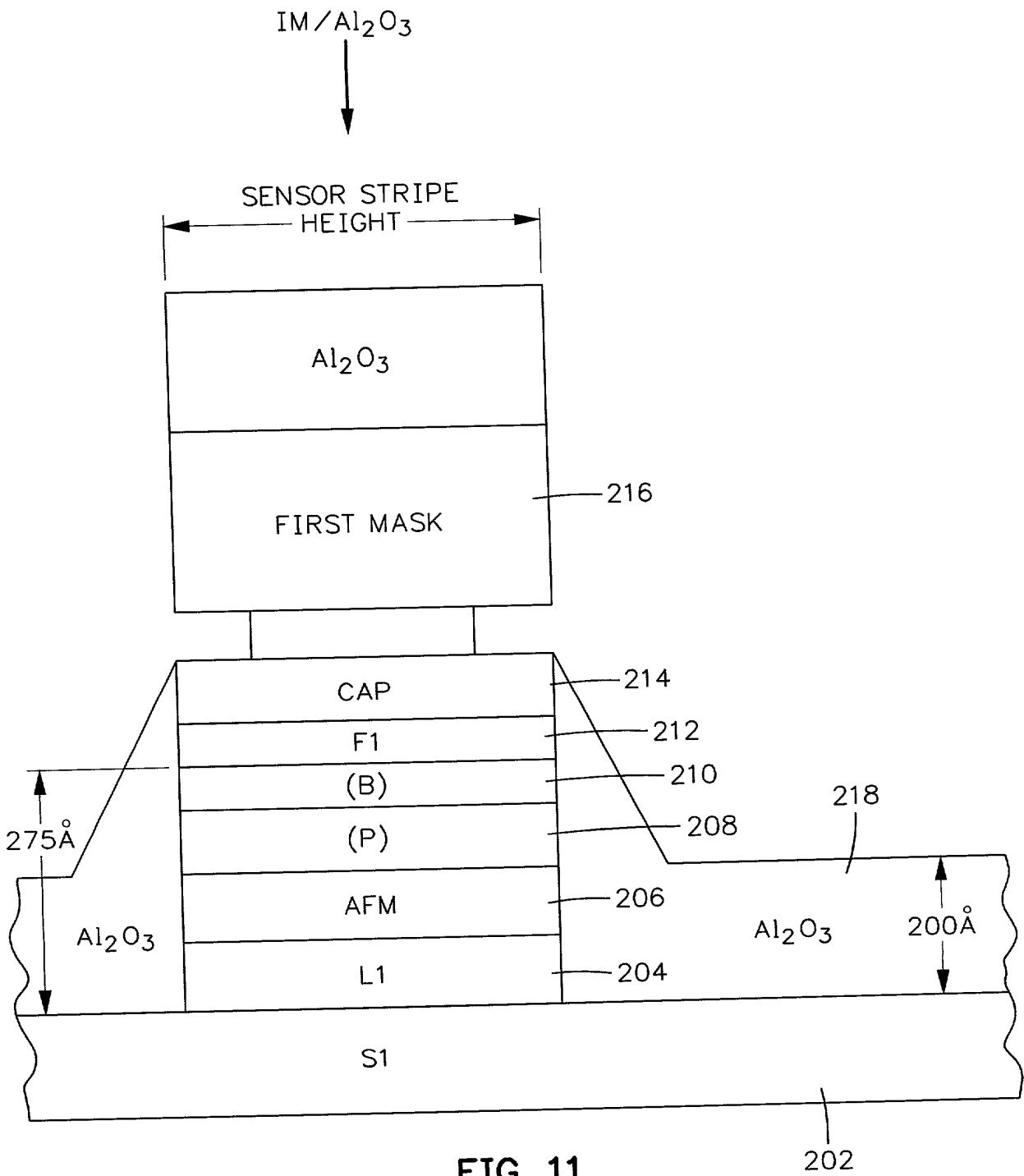


FIG. 10



REMOVE 1ST MASK AND SPUTTER ETCH AWAY CAP

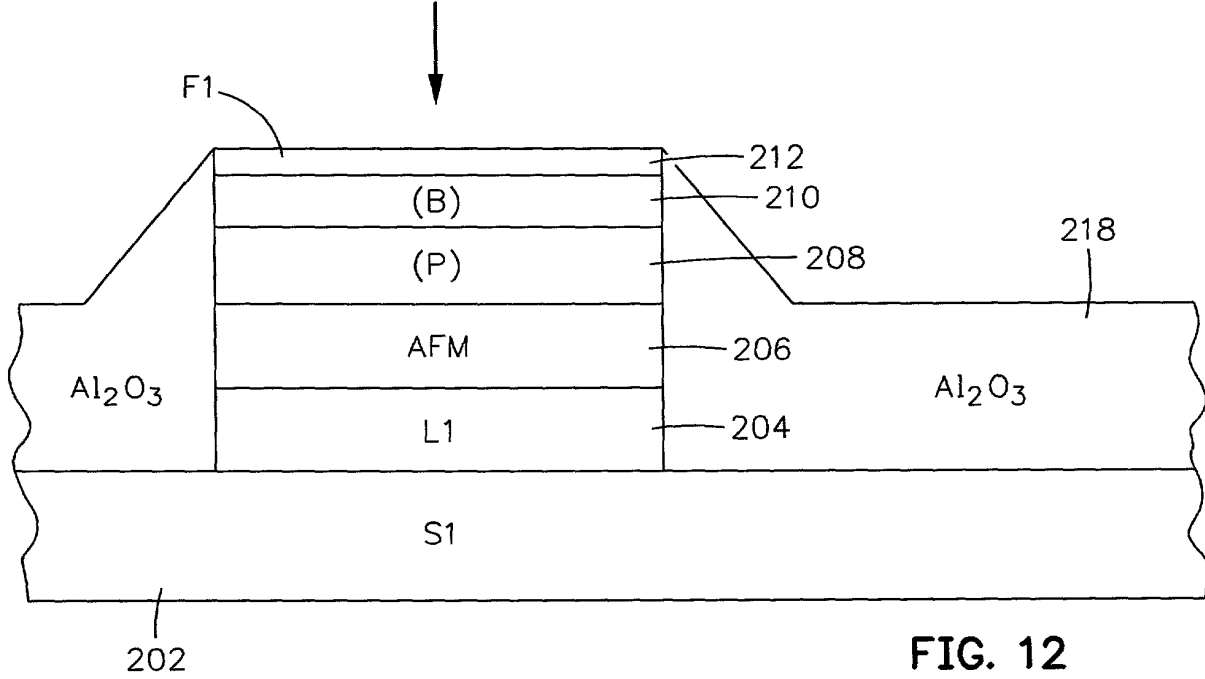


FIG. 12

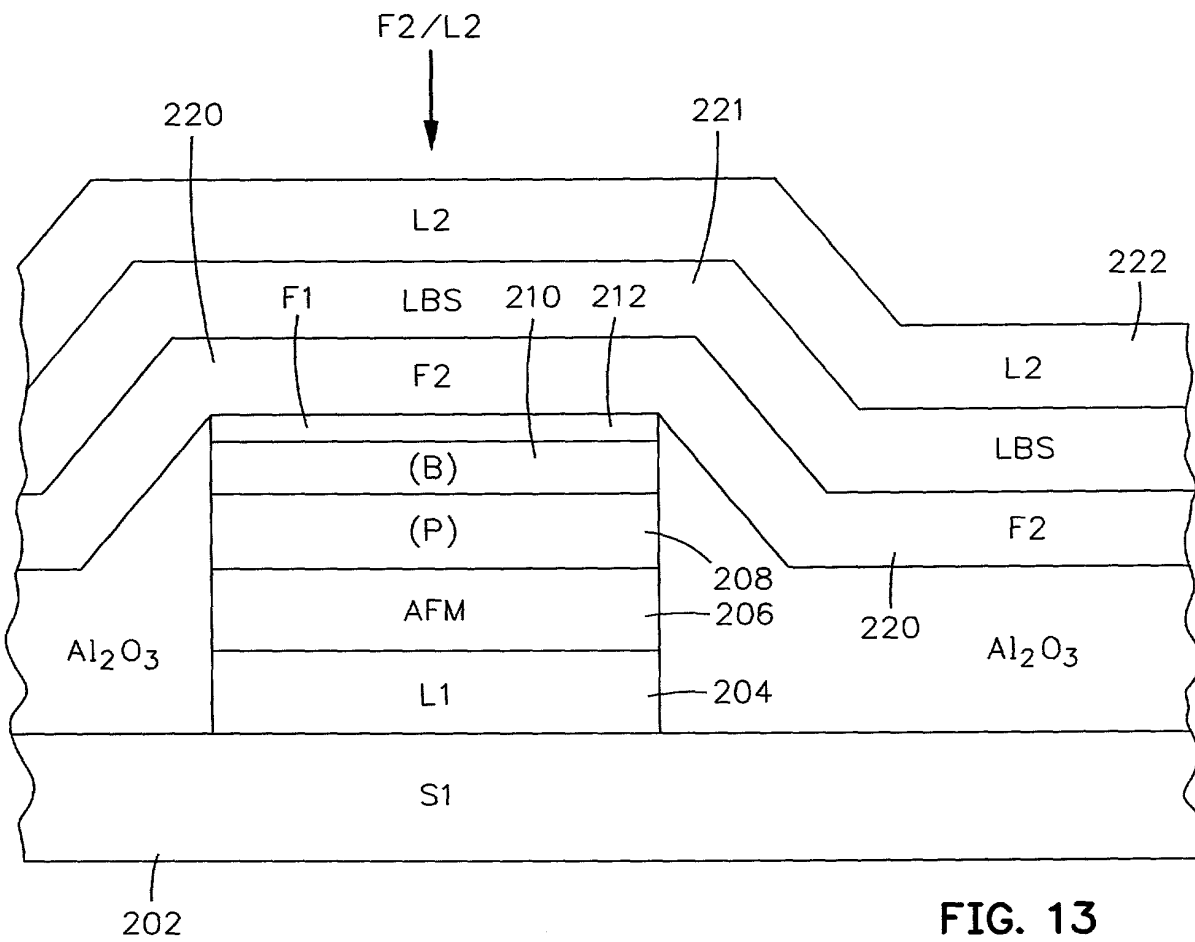


FIG. 13

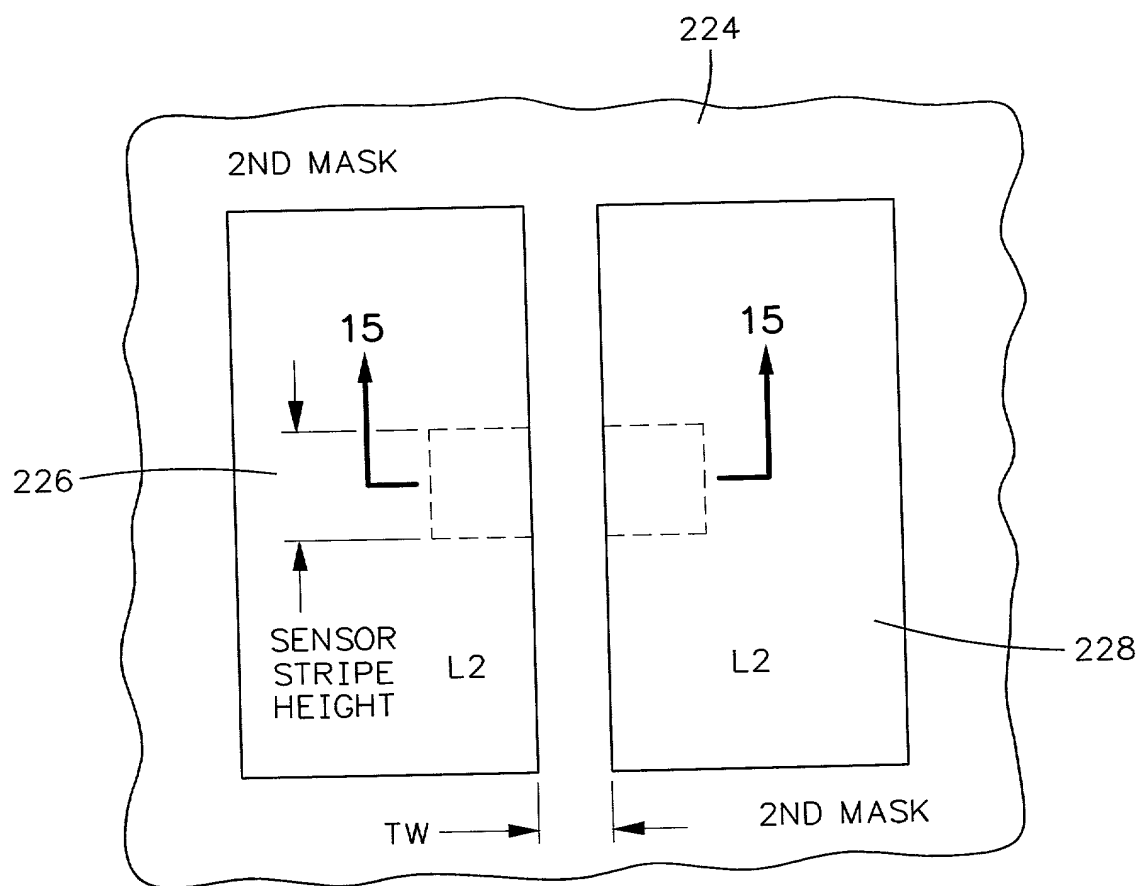


FIG. 14

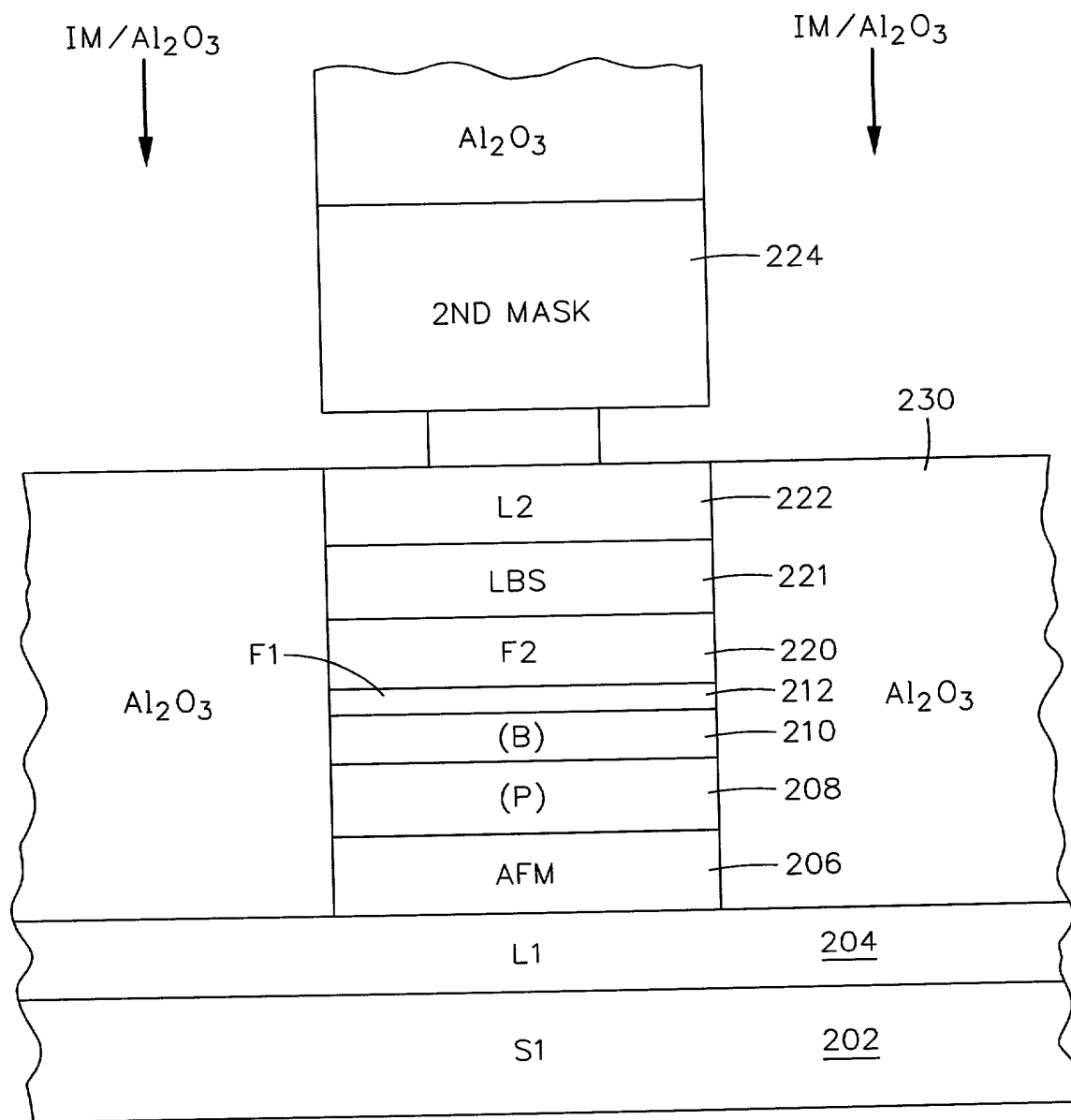


FIG. 15

REMOVE 2ND MASK
DEPOSIT S2

FIG. 16

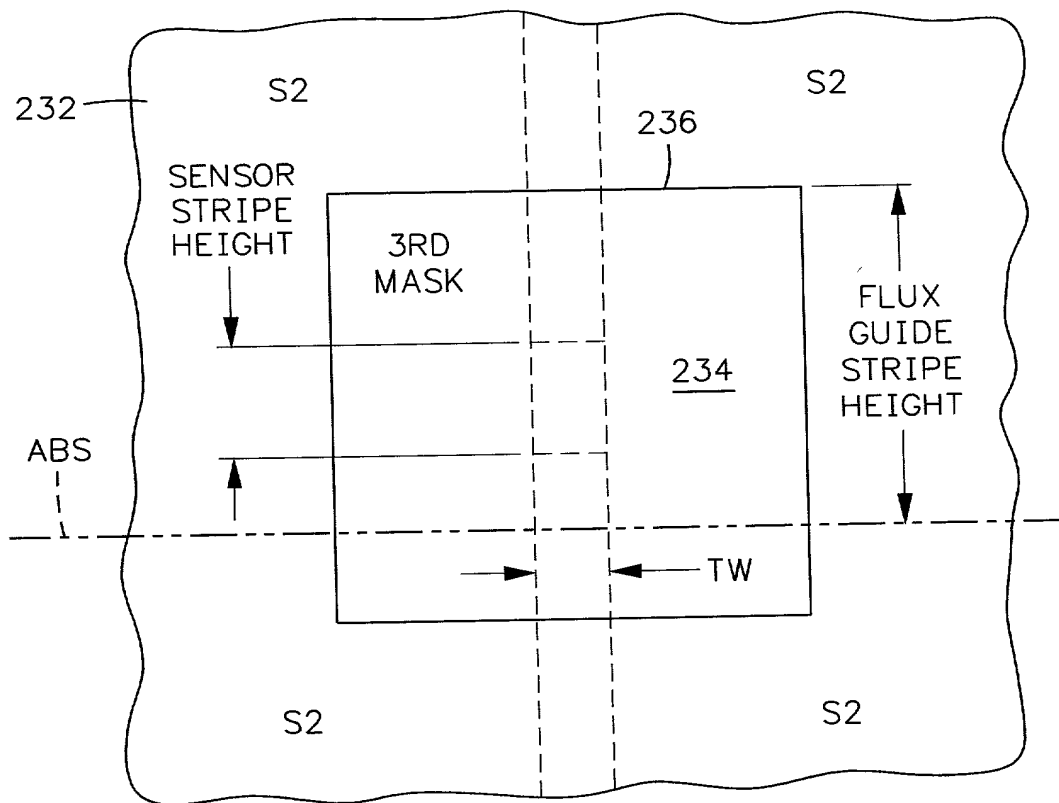


FIG. 17

ION MILL
REMOVE 3RD MASK

FIG. 18

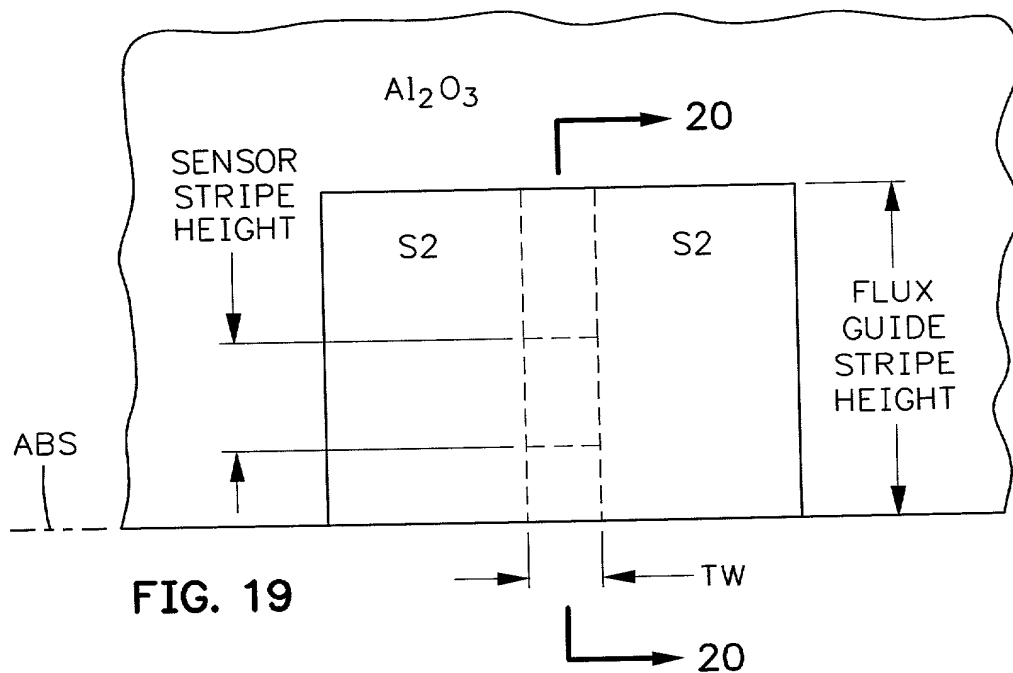


FIG. 19

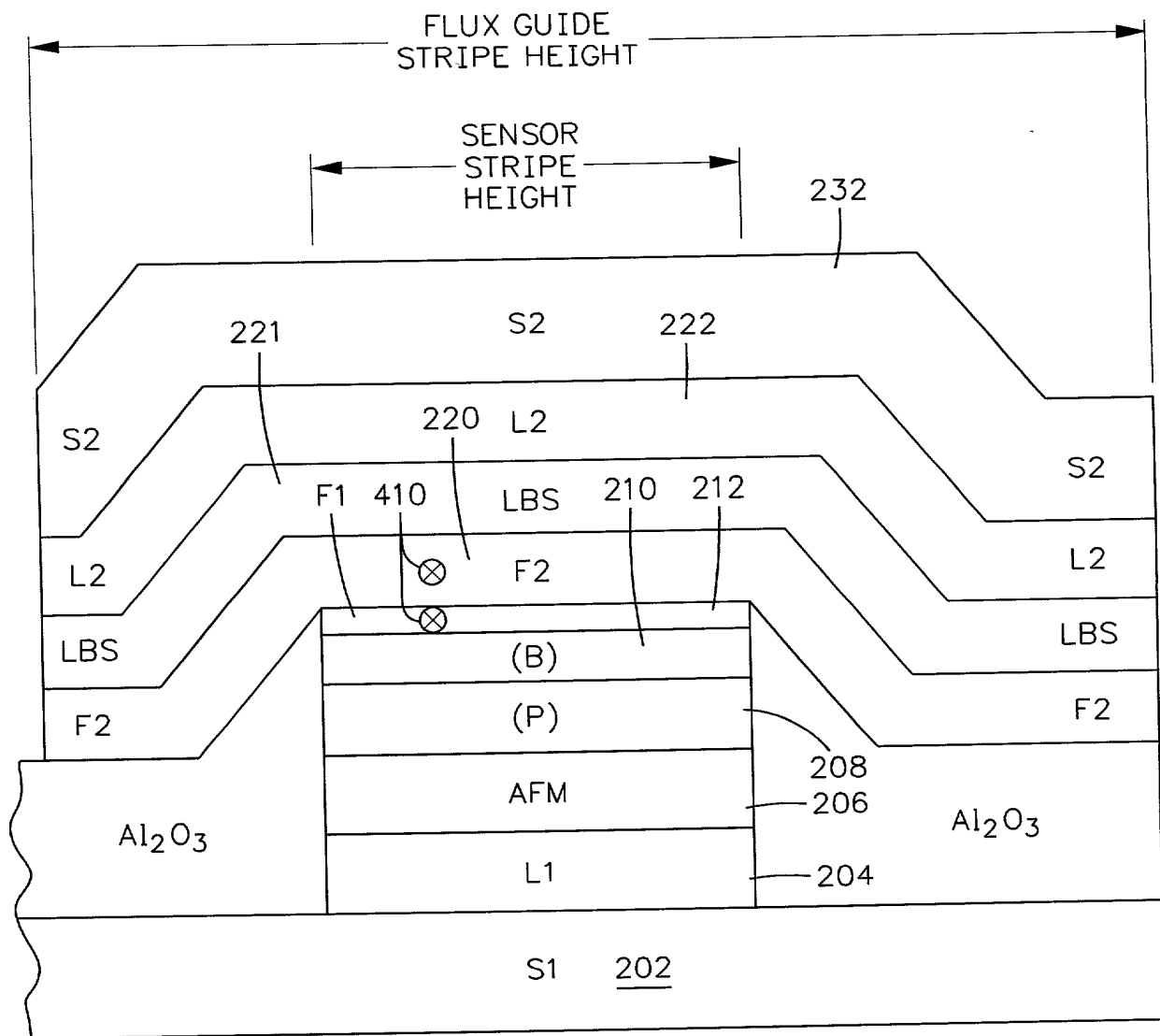


FIG. 20

ABS

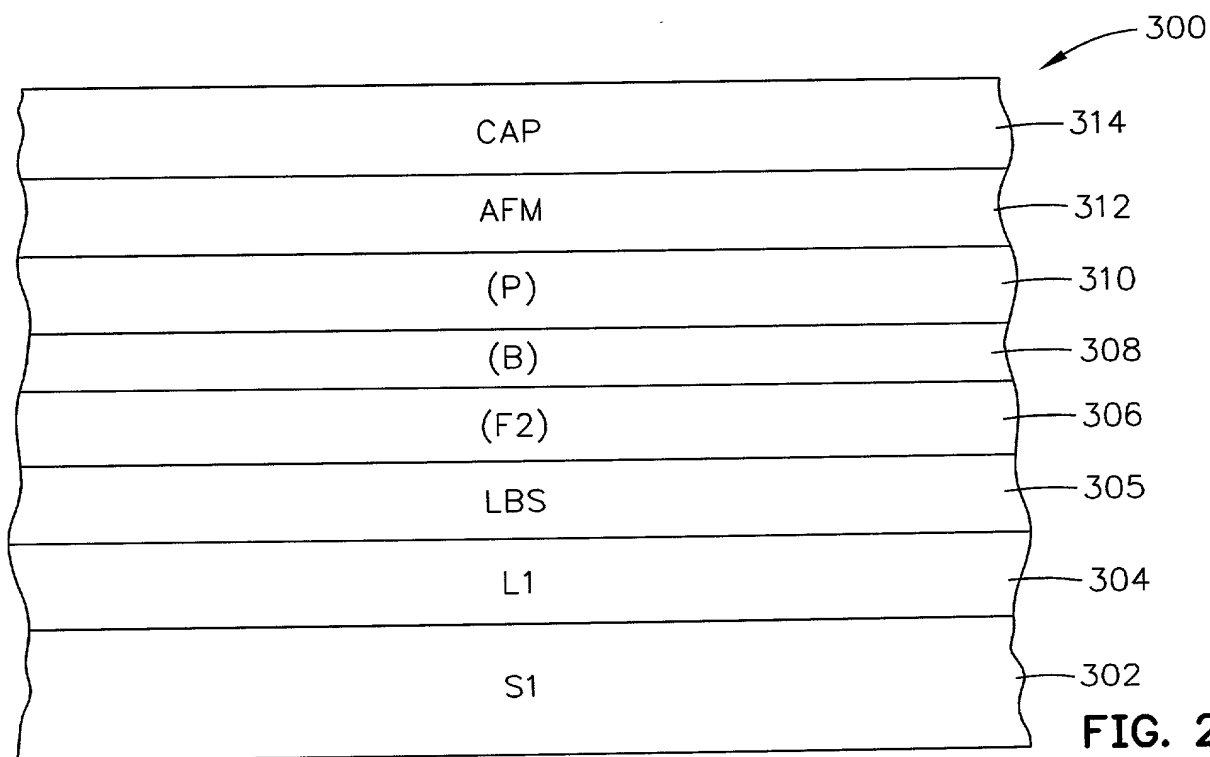


FIG. 21

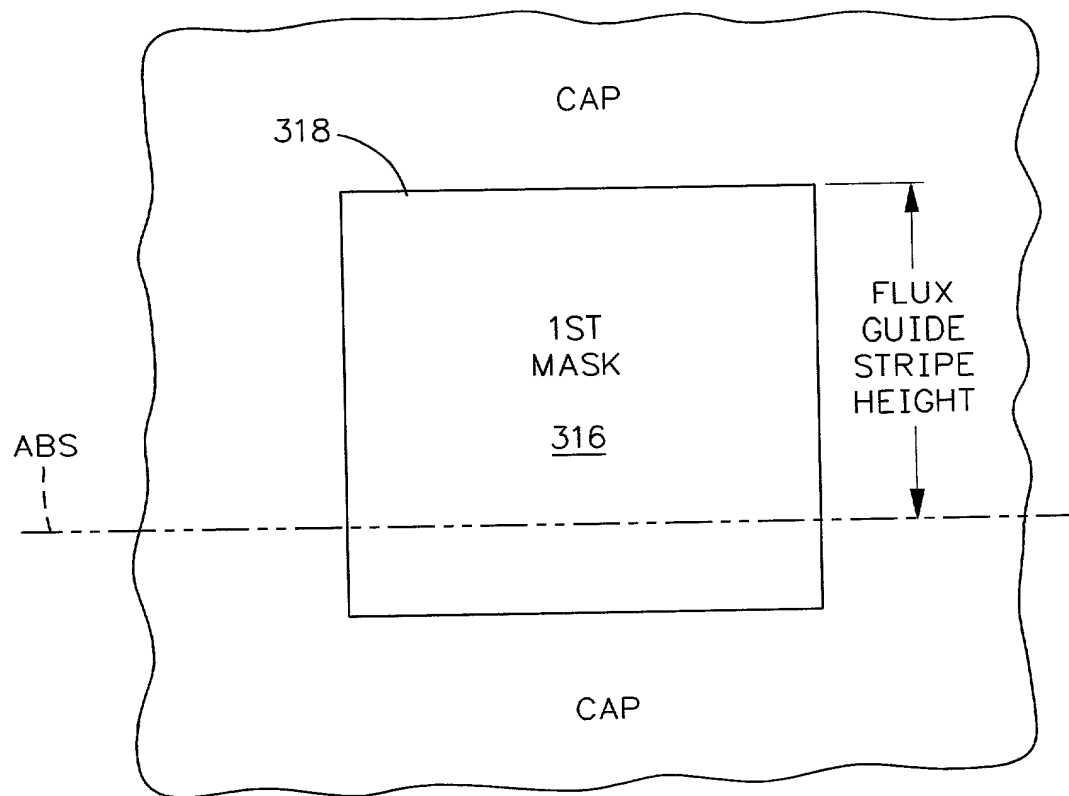
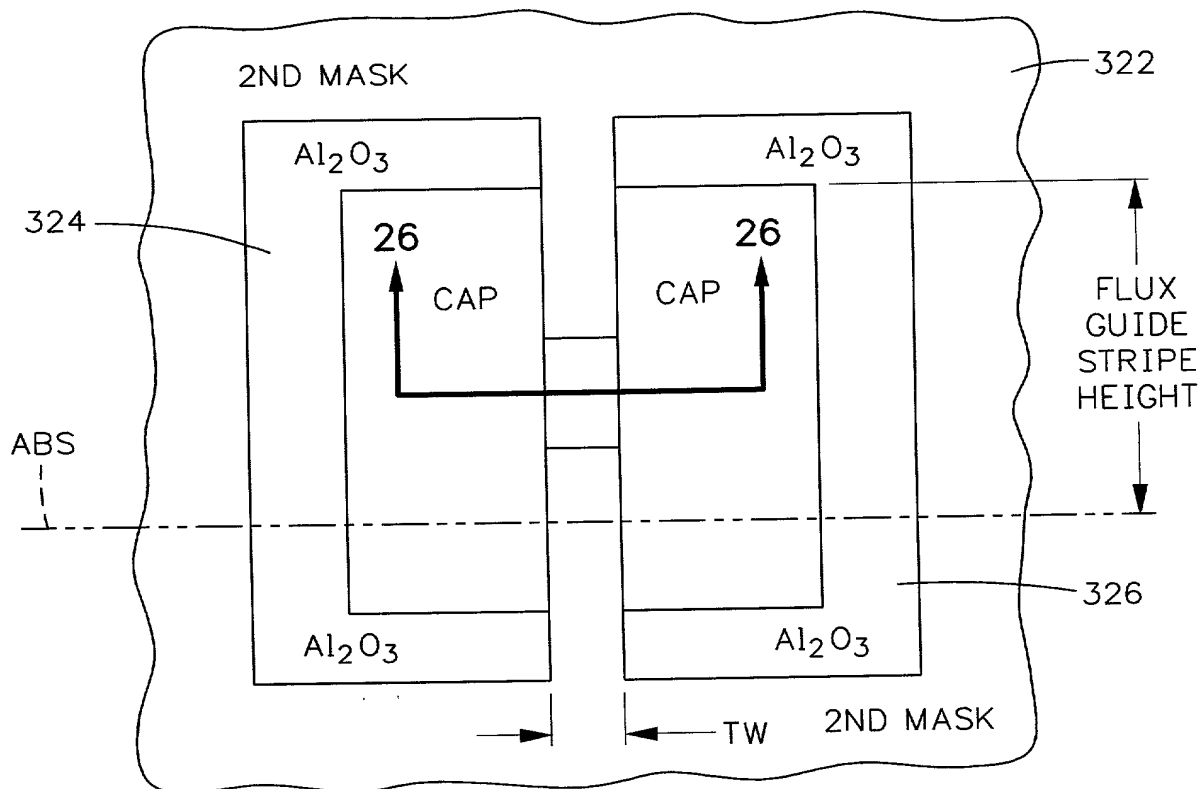
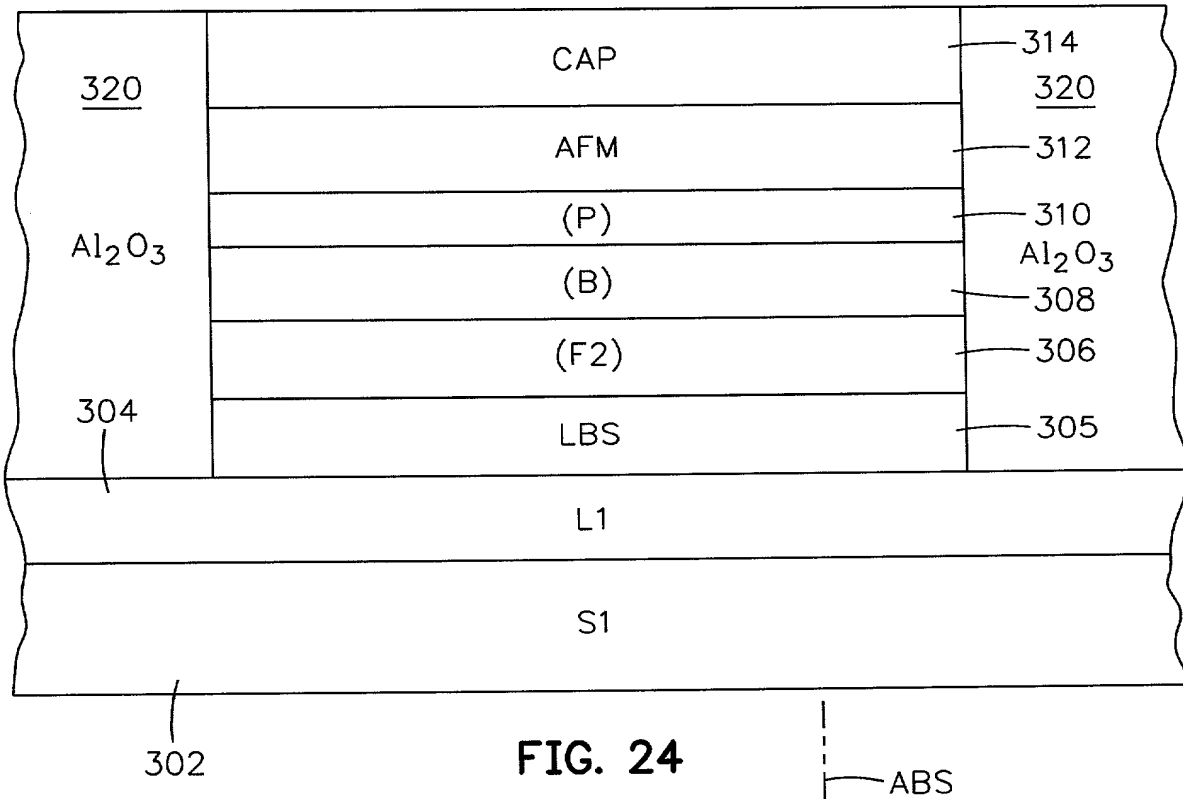


FIG. 22

ION MILL CAP
DEPOSIT ALUMINA
REMOVE 1ST MASK

FIG. 23



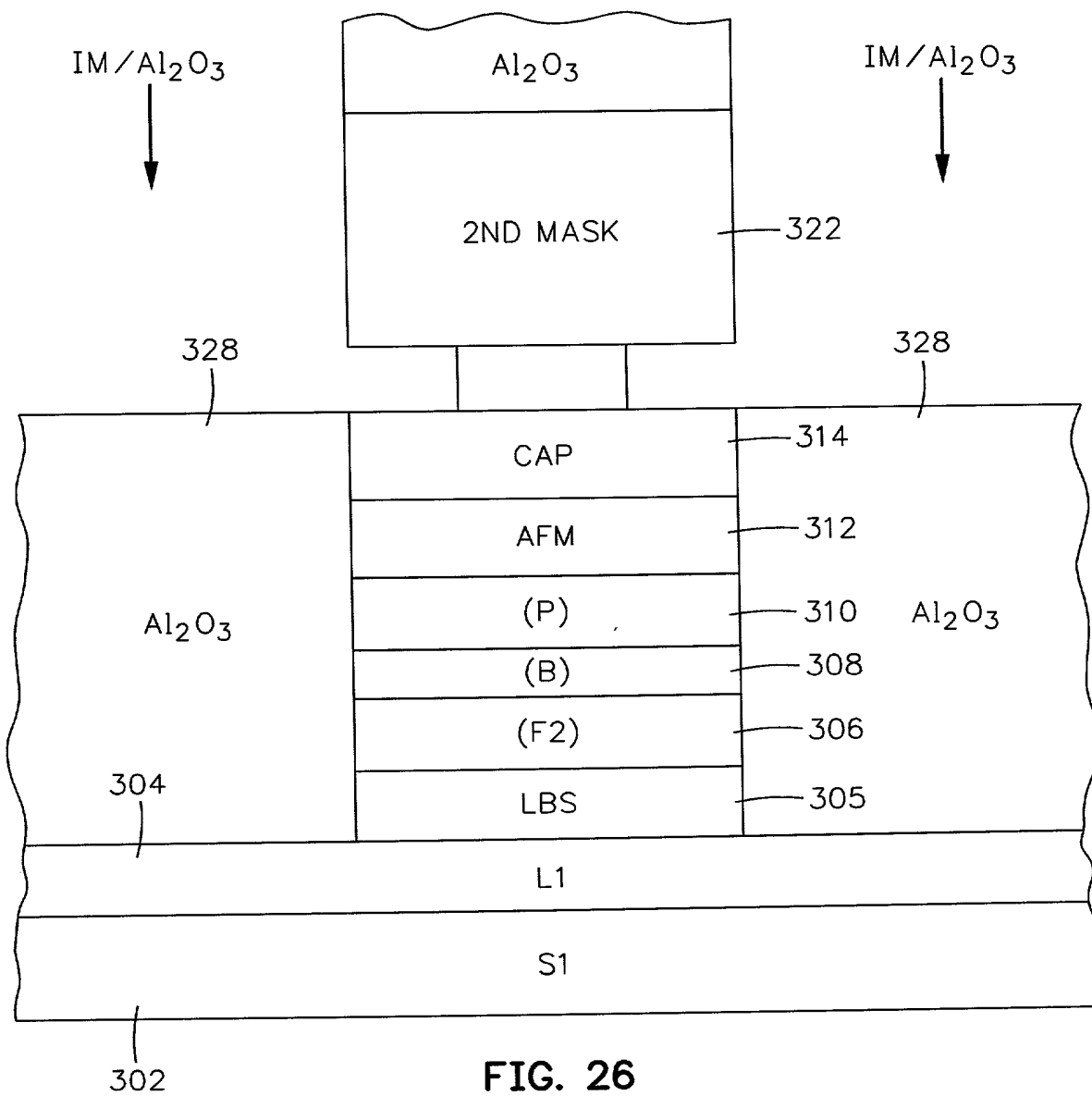


FIG. 26

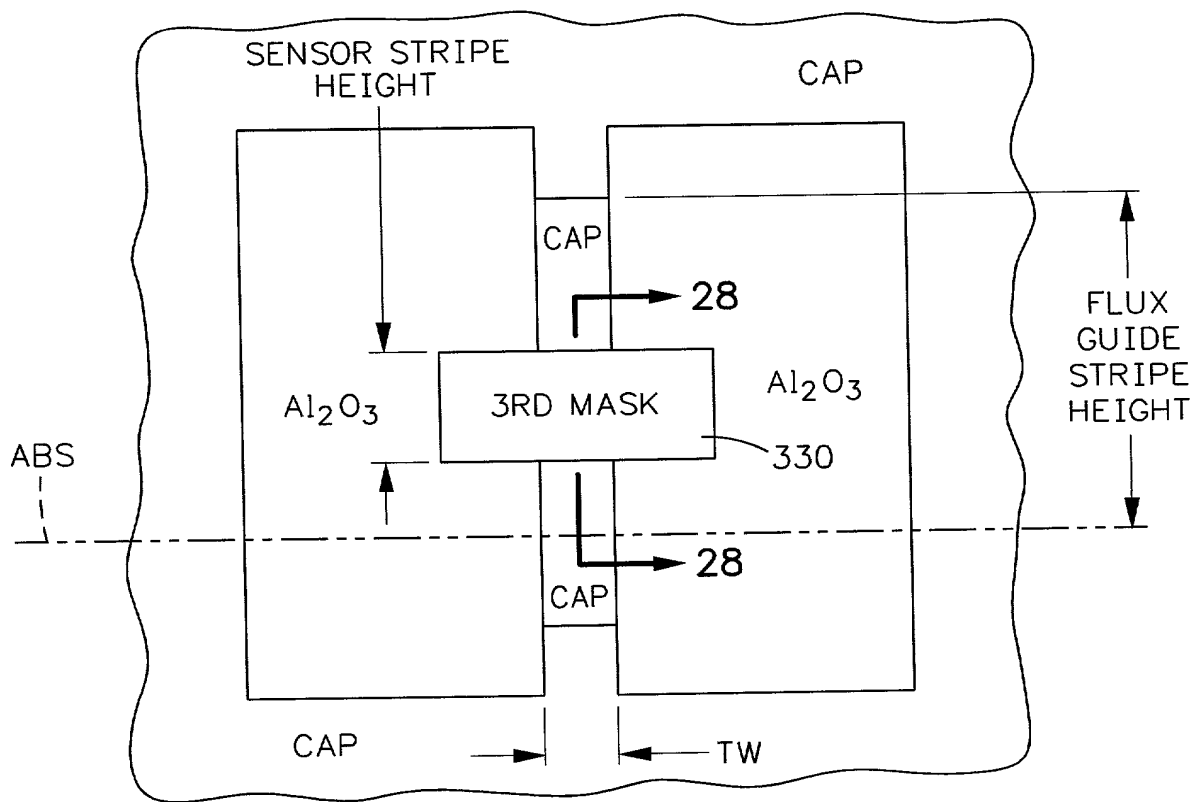


FIG. 27

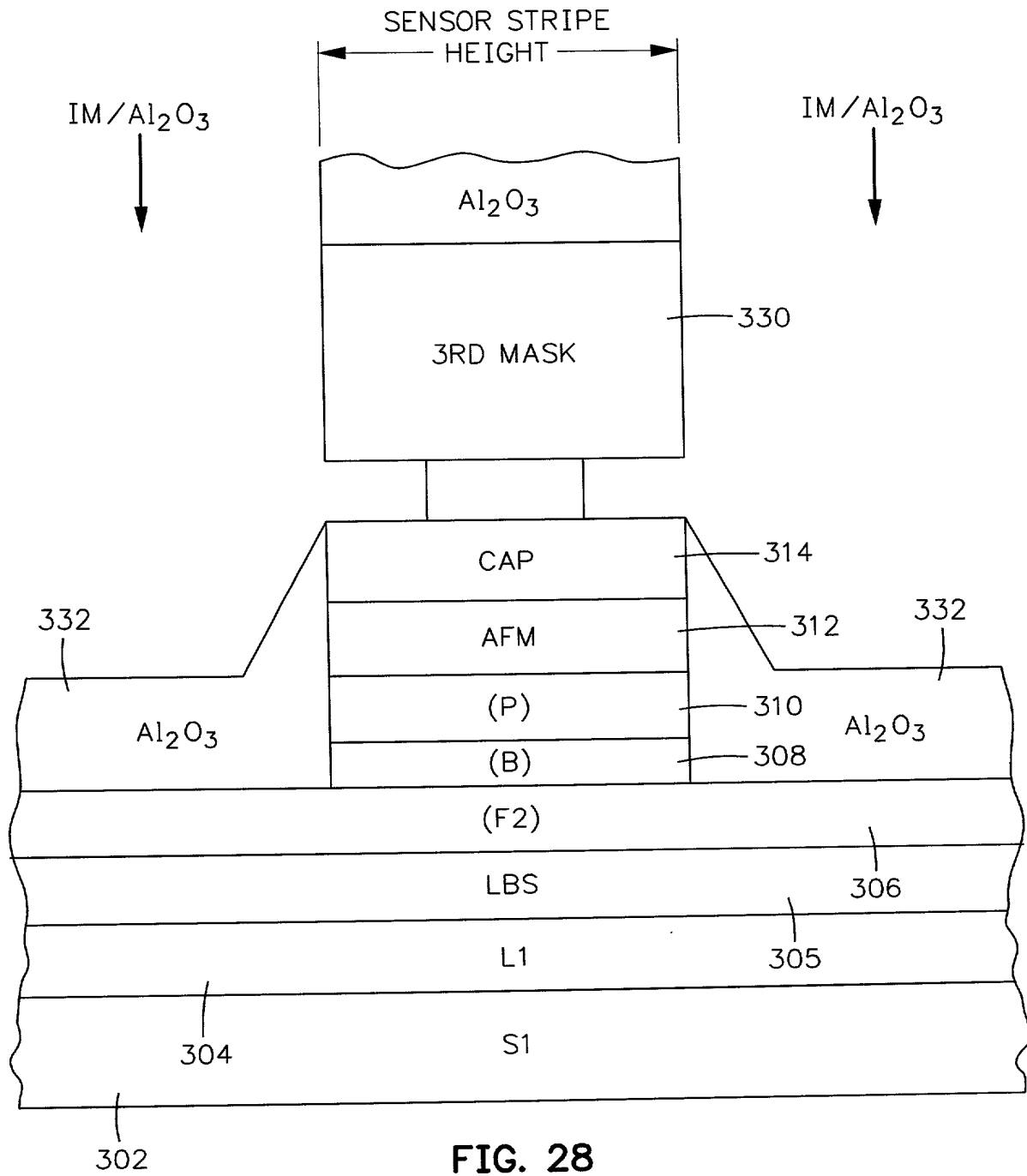


FIG. 28

REMOVE 3RD MASK
DEPOSIT L2/S2

FIG. 29

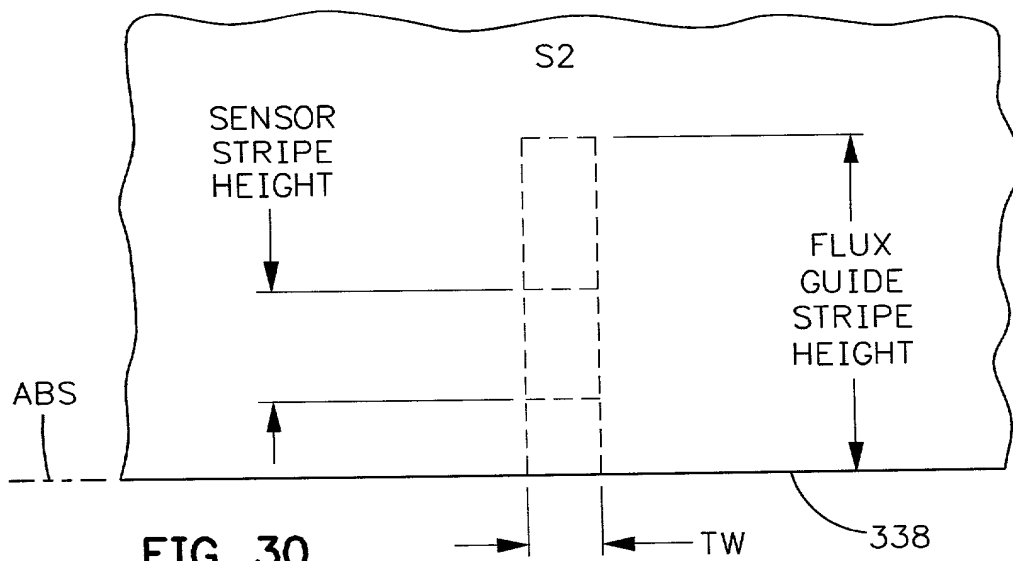


FIG. 30

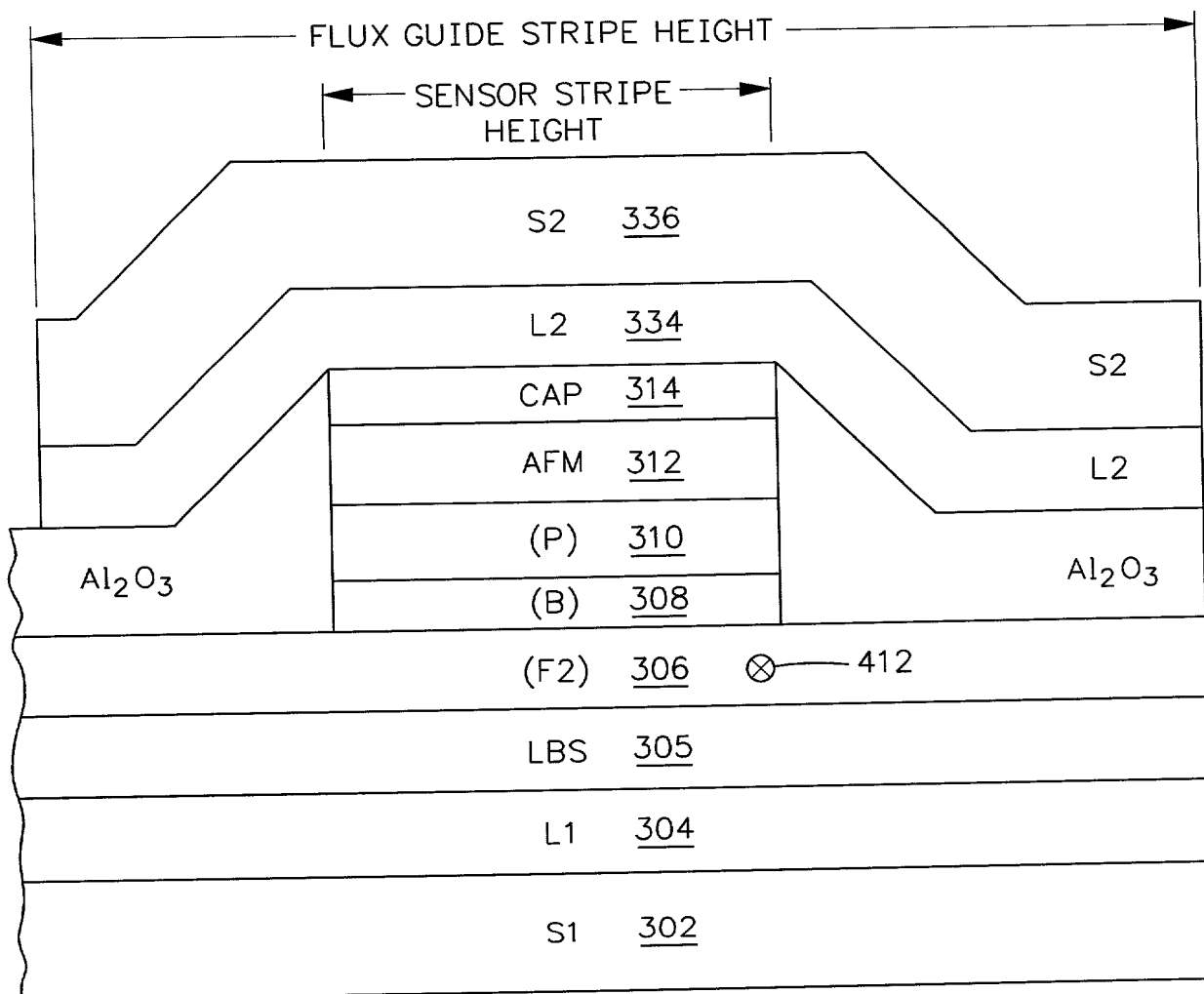


FIG. 31

ABS

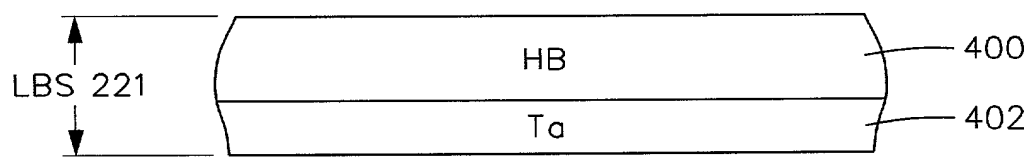


FIG. 32

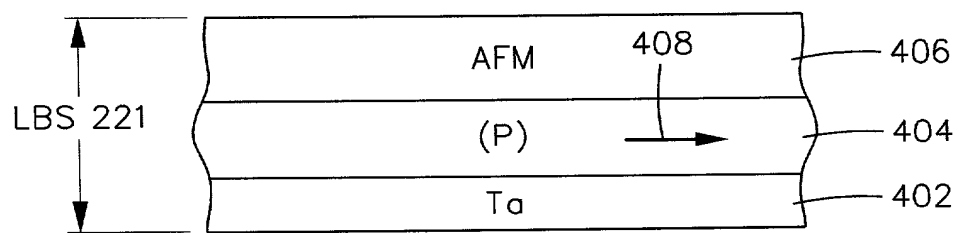


FIG. 33

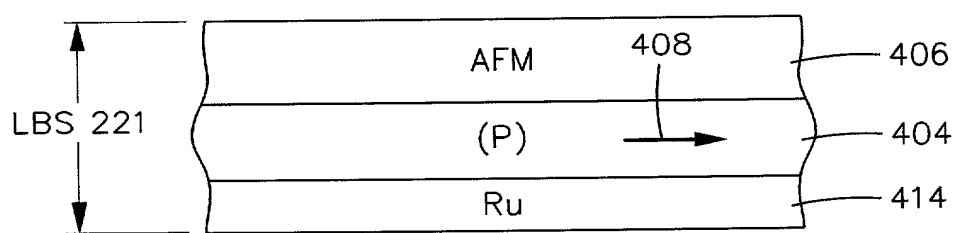


FIG. 34